



ITW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/614,345

Confirmation No.: 7853

In re Application of

Masaaki KURIHARA et al.

Group Art Unit: 1756

Filed: July 8, 2003

Examiner: Unassigned

For: PHASE MASK FOR FORMING DIFFRACTION GRATING, METHOD OF
FABRICATING PHASE MASK AND METHOD FOR FORMING DIFFRACTION GRATING

STATUS INQUIRY LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It would be appreciated if you would indicate the status of the above-identified application below, including an indication as to when the next communication can be expected, and return this sheet to the undersigned.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.

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March 28, 2005
Date

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